

<b>Notice of References Cited</b>	Application/Control No. 10/750,141	Applicant(s)/Patent Under Reexamination YAMAKAWA ET AL.	
	Examiner Rebecca M. Stadler	Art Unit 1754	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0072994	04-2004	Herr et al.	530/350
*	C	US-6,401,526	06-2002	Dai et al.	73/105
*	D	US-6,696,022	02-2004	Chan et al.	422/99
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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